NASA TECH BRIEF



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Copper and Nickel Adherently Electroplated on Titanium Alloy

The problem:

Electroplating tightly adherent coatings of copper and nickel on Ti-6Al-4V alloy. Plating either with copper or nickel was required to protect the titanium alloy against attack by liquid oxygen.

The solution:

A process consisting of anodic treatment of the titanium alloy in a solution of hydrofluoric and acetic acids, followed by electroplating with the copper or nickel.

How it's done:

The process includes the following steps:

Anodic Treatment

- 1. Connect the titanium alloy parts anodically outside the tank. Adjust the voltage to 5 volts. Immerse the thoroughly cleaned and dried parts in a solution containing 875 ml of glacial acetic acid and 125 ml of 70 percent hydrofluoric acid. Adjust the voltage (within 1 minute) to 10 volts and maintain constant for 30 minutes.
- 2. Transfer to a rinse tank within 30 seconds. *Do not drain*. Rince thoroughly and transfer to plating tank.

Copper Plating

- 1. Connect parts and apply cathodic voltage of approximately 3 volts. Immerse parts in copper fluoroborate solution. Adjust current to 0.5 asi for 12 minutes. Do not interrupt current during plating since even a momentary stoppage may result in a laminated deposit.
- 2. Rinse thoroughly and dry.

Nickel Plating

- Connect parts and apply cathodic voltage of approximately 3 volts. Immerse parts in nickel strike solution (Wood's nickel bath or all-chloride bath).
 Adjust current to 0.3 asi for 3 minutes. Do not interrupt current during plating since even a momentary stoppage will result in a laminated deposit.
- 2. Rinse thoroughly.
- 3. Connect parts and apply 3 cathodic volts. Immerse parts in nickel (sulfamate) plating solution. Adjust current to 0.5 asi for 10 minutes. Do not interrupt the current during plating, since even a momentary stoppage will result in a laminated deposit.
- 4. Rinse thoroughly and dry.

Note:

Inquiries concerning this process may be directed to:

Technology Utilization Officer Marshall Space Flight Center Huntsville, Alabama 35812 Reference: B67-10532

Patent status:

No patent action is contemplated by NASA.

Source: Everett E. Brown of The Boeing Company under contract to Marshall Space Flight Center (MFS-13952)

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